

Form PTO-1449 US Dept. of Commerce PATENT & TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY DOCKET NO. D/A3207I	APPLICATION NO. 10/772,564
	APPLICANT Jun Ma et al.	
	FILING DATE 2/5/04	GROUP ART UNIT 2883

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE	CLASS	SUB CLASS
RA	5,706,041	01/06/1998	Joel A. Kubby	347	65
R	5,851,412	12/22/1998	Joel A. Kubby	216	27
R	6,362,512 B1	03/26/2002	Joel A. Kubby et al.	257	415
R	6,379,989 B1	04/30/2002	Joel A. Kubby et al.	438	52
R	6,002,507	12/14/1999	Philip D. Floyd et al.	359	201
R	6,014,240	01/11/2000	Philip D. Floyd et al.	359	201
R	5,909,078	06/01/1999	Robert L. Wood et al.	310	307
R	5,994,816	11/30/1999	Vijayakumar R. Dhuler et al.	310	307
R	6,023,121	02/08/2000	Vijayakumar R. Dhuler et al.	310	307
R	6,114,794	09/05/2000	Vijayakumar R. Dhuler et al.	310	307

## FOREIGN PATENT DOCUMENTS

	COUNTRY	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	TRANSLATION Y/N

## OTHER DOCUMENTS (Including Author (in CAPS), Title, Publication Date, Pages, etc.)

R	Yogesh B. Gianchandani and Khalil Najafi, "Bent-Beam Strain Sensors," Journal of Microelectromechanical Systems, Vol. 5, No.1, March 1996, pages 52-58
R	Long Que, Jae-Sung Park and Yogesh B. Gianchandani, "Bent-Beam Electrothermal Actuators," Journal of Microelectromechanical Systems, Vol. 10, No. 2, June 2001, pages 247-254
R	John M. Maloney, Don L. DeVoe and David S. Schreiber, "Analysis and Design of Electrothermal Actuators Fabricated from Single Crystal Silicon," Proceedings ASME International Mechanical Engineering Conference and Exposition, Orlando, FL, pages 233-240, 2000
EXAMINER	DATE CONSIDERED 3/9/05
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE	CLASS	SUB CLASS
R	6,255,757 B1	07/03/2001	Vijayakumar R. Dhuler et al.	310	307
R	6,324,748 B1	12/04/2001	Vijayakumar R. Dhuler et al.	29	622
R	6,360,539 B1	03/26/2002	Edward A. Hill et al.	60	528
R	2003/0134445 A1	07/17/2003	Joel A. Kubby	438	31
R	2003/0086641 A1	05/08/2003	Joel A. Kubby et al.	385	24

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EXAMINER	Ryan J. 1816
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